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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURES EXAMINING
GROUP 2813

Docket No.: 0630-1951P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Lee-Yeun HWANG

Application No.: 10/767,203

Confirmation No.: 5731

Filed: January 30, 2004

Art Unit: 2813

For: HIGH VOLTAGE DEVICE HAVING
POLYSILICON REGION IN TRENCH AND
FABRICATING METHOD THEREOF

Examiner: H. A. Doty

REPLY UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Office Action dated April 6, 2006, the period for response having been extended two (2) month until September 6, 2006, the following remarks are respectfully submitted in connection with the above-identified application.